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MAR-24-2004 WED 05:35 PM SENNIGER POWERS

FAX NO. 3142314342

P. 01

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FACSIMILE TRANSMITTAL COVER SHEET

DATE: March 24, 2004 SPLR FILE #: MEMC 02-0051(3032.1) SENT BY: DEP

FACSIMILE NUMBER BEING CALLED: 1-703-746-9195

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Edward J. Hejlek

March 24, 2004

Application of Henry F. Erk et al.
Serial No. 10/665,982
Filed September 18, 2003
Confirmation No. 5374
For PROCESS FOR ETCHING SILICON WAFERS
Attorney Docket MEMC 02-0051 (3032.1)

Art Unit 1763

Office of Initial Patent Examination's
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Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

We have received the filing receipt for the above-identified patent application.

The receipt shows the Domestic Priority Data as:

This appln claims benefit of 60/411,544 09/18/2002
and claims benefit of 60/487,662 12/17/2003

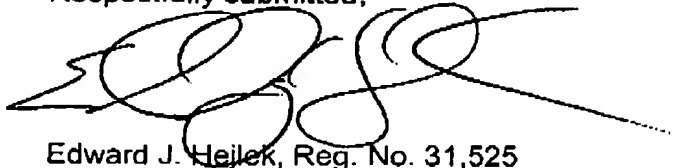
whereas the correct information is

This appln claims benefit of 60/411,544 09/18/2002
and claims benefit of 60/487,662 07/16/2003.

A copy of the Filing Receipt with the changes noted thereon is enclosed.

Please send us a corrected filing receipt.

Respectfully submitted,



Edward J. Hejlek, Reg. No. 31,525

EJH/dep

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/665,982	09/18/2003	1763	3292	MEMC 02-0051 (3032.1)	16	129	8

CONFIRMATION NO. 5374

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UPDATED FILING RECEIPT



OC000000011991979

Date Mailed: 03/01/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment For Published Patent Application

MEMC Electronic Materials, Inc.; ✓

Domestic Priority data as claimed by applicant

This appln claims benefit of 60/411,544 09/18/2002 ✓
 and claims benefit of 60/487,662 12/47/2003 * 07/16/2003

Foreign Applications

If Required, Foreign Filing License Granted: 12/11/2003

Projected Publication Date: 06/10/2004 ✓

Non-Publication Request: No

JW

Early Publication Request: No

Title

Process for etching silicon wafers ~

Preliminary Class

216

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